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09/388,826

SUBJECT/MESSAGE:

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Practitioner's Docket No. MI22-1208

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Li et al., Weimin

Application No.: 09/388,826

Group No.: 2813

Filed: 09/01/99

Examiner: E.J. Kielin

For: Low k Interlevel Dielectric Layer Fabrication Methods

Assistant Commissioner for Patents
Washington, D.C. 20231

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Response to May 1, 2002 Office Action

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Robin Saldivia


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23
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/388,826
Filing Date September 1, 1999
Inventor Weimin Li et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner E.J. Kielin
Attorney's Docket No. MI22-1208
Title: Low k Interlevel Dielectric Layer Fabrication Methods

RESPONSE TO MAY 1, 2002 OFFICE ACTION

To: Box Non-Fee Amendment
Assistant Commissioner for Patents
Washington, D.C. 20231

From: Frederick M. Fliegel, Ph.D.
Tel. 509-624-4276; Fax 509-838-3424
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Spokane, WA 99201-3828

Sir:

Responsive to the Office Action dated May 1, 2002, Applicant remarks
as follows: